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**Dickinson et al.**

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(54) **RACK FOR USE WITH A TEMPERATURE CONTROLLED BATH, AND A RELATED METHOD**

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***B01L 7/02*** (2006.01)

(52) **U.S. Cl.**
CPC .. ***B01L 7/02*** (2013.01); ***B01L 9/06*** (2013.01); *B01L 2300/0609* (2013.01); *B01L 2300/0809* (2013.01); *B01L 2300/185* (2013.01)

(58) **Field of Classification Search**
CPC ..... B01L 9/06
See application file for complete search history.

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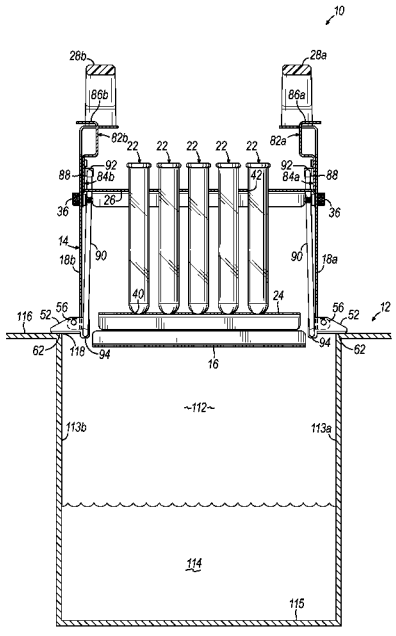
(57) **ABSTRACT**

A rack is provided for use with a temperature controlled bath having a housing containing a reservoir with a supply of working fluid and an opening providing access to the reservoir. The rack includes a rack body, and a vessel support supported by the rack body and configured for supporting at least one vessel. The rack further includes a supporting foot assembly supported by the rack body and including a plurality of support feet. Each support foot is configured for movement between a stowed position and a deployed position.

**11 Claims, 11 Drawing Sheets**



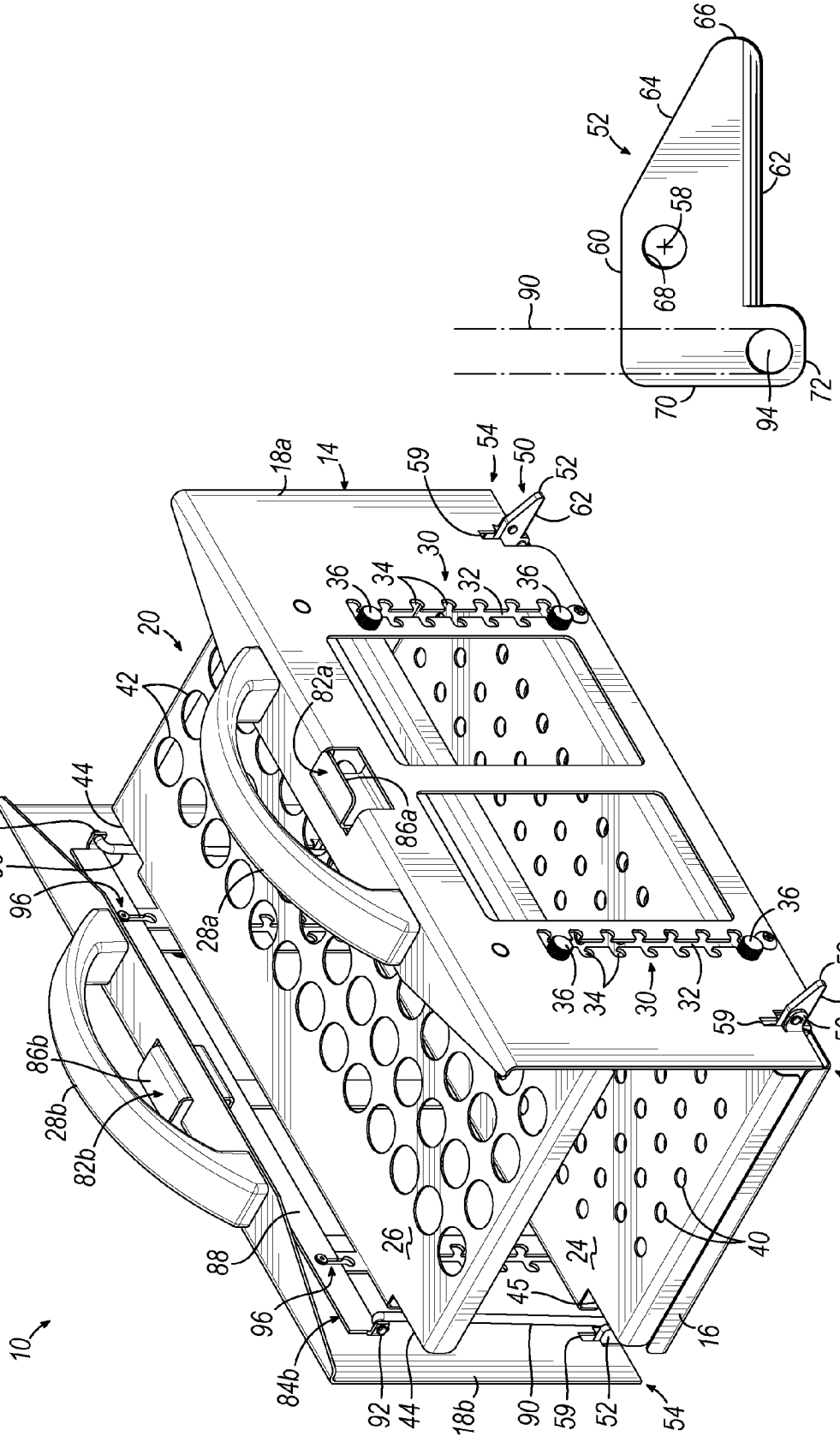

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FIG. 1


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FIG. 1A

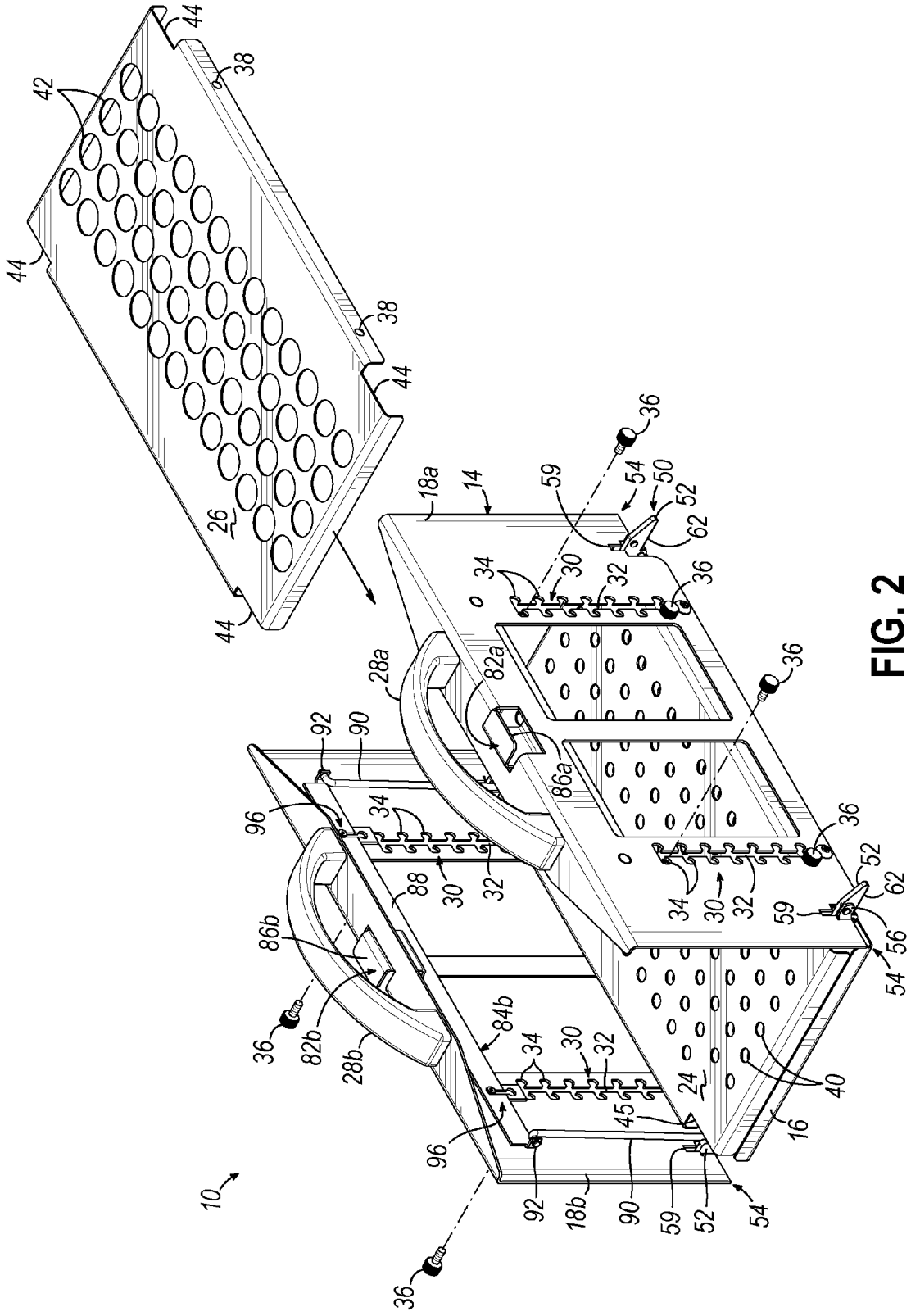
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FIG. 2

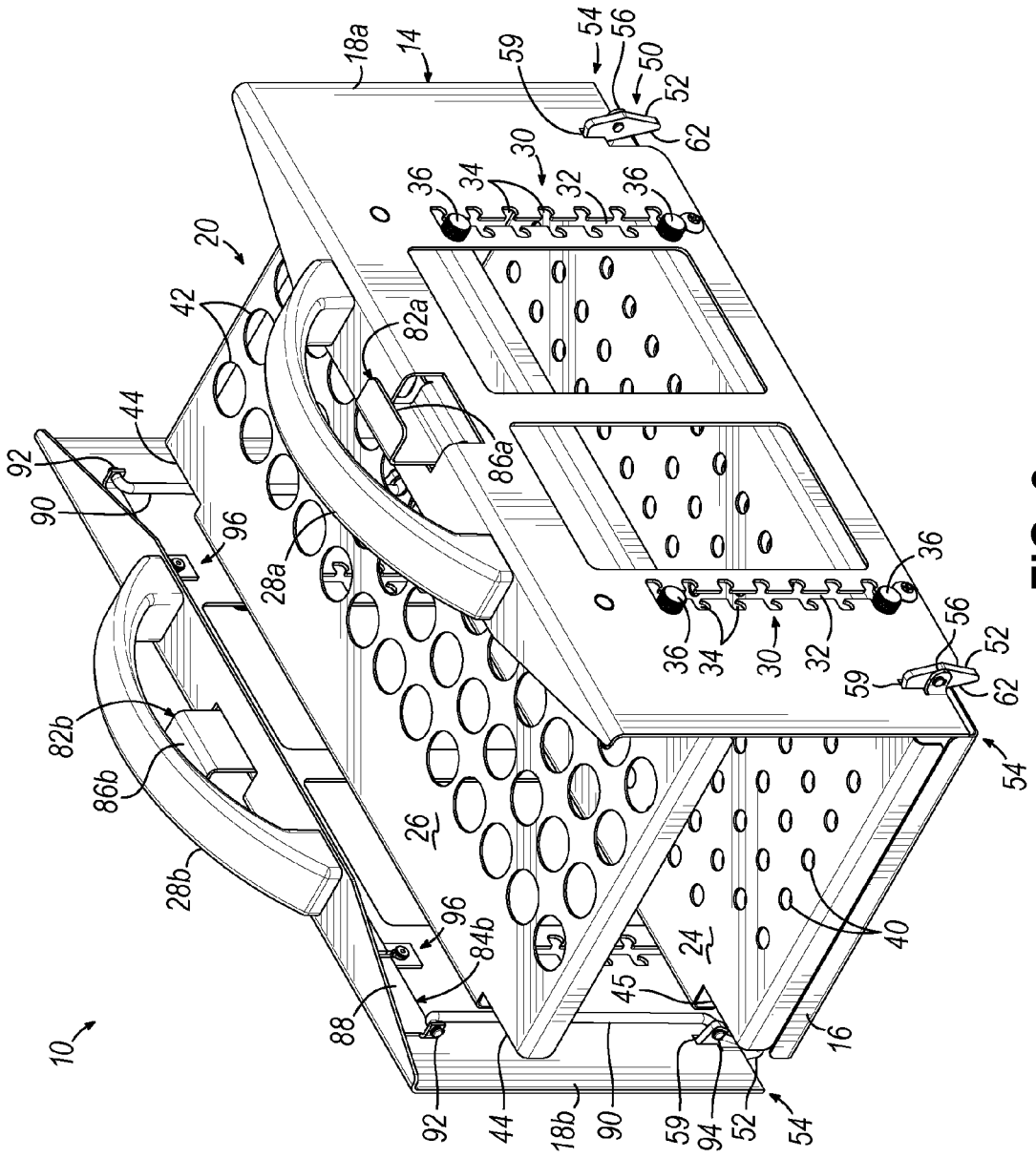
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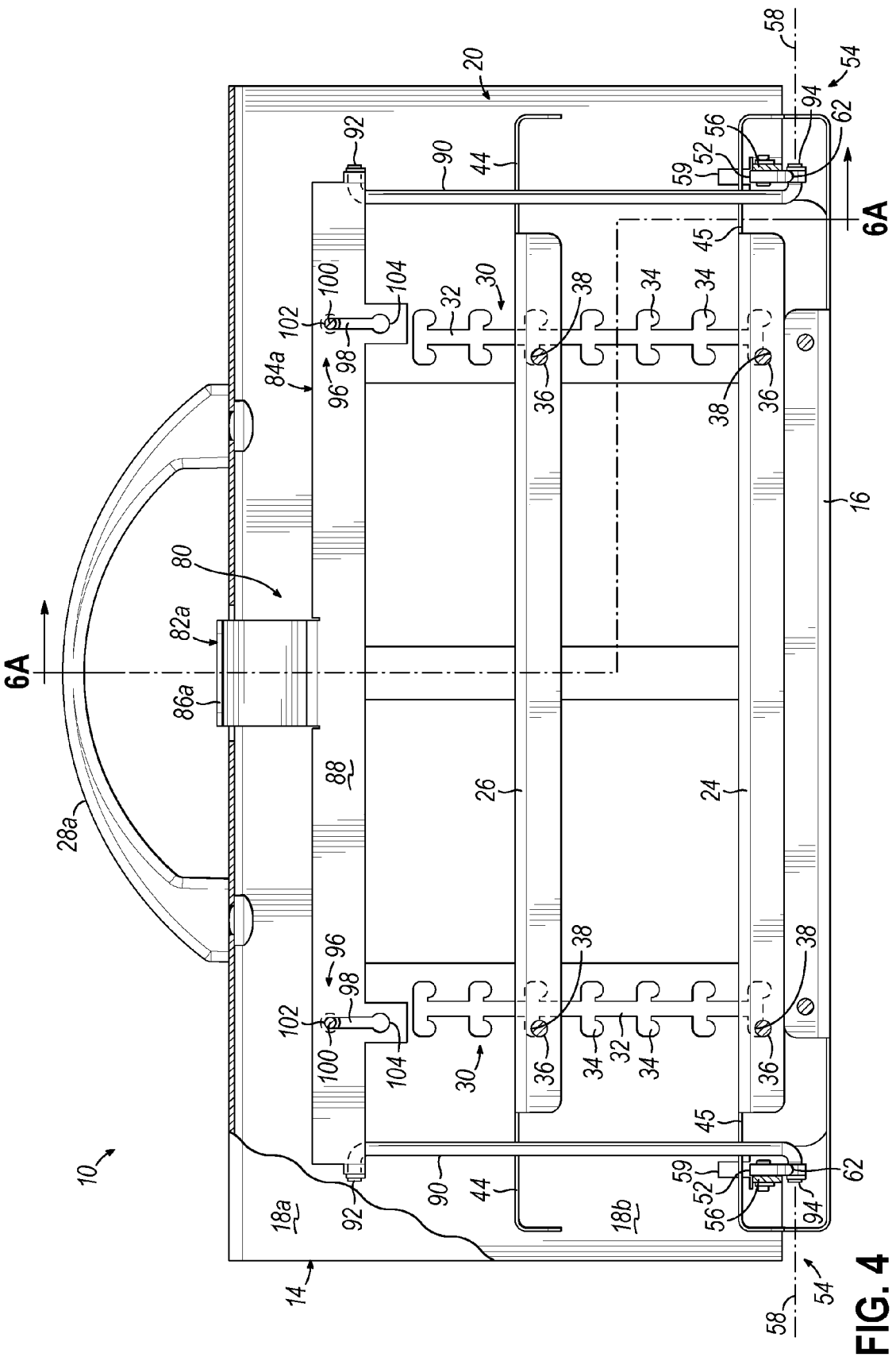
FIG. 3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96
98
100
102
104
6A
6A

FIG. 4

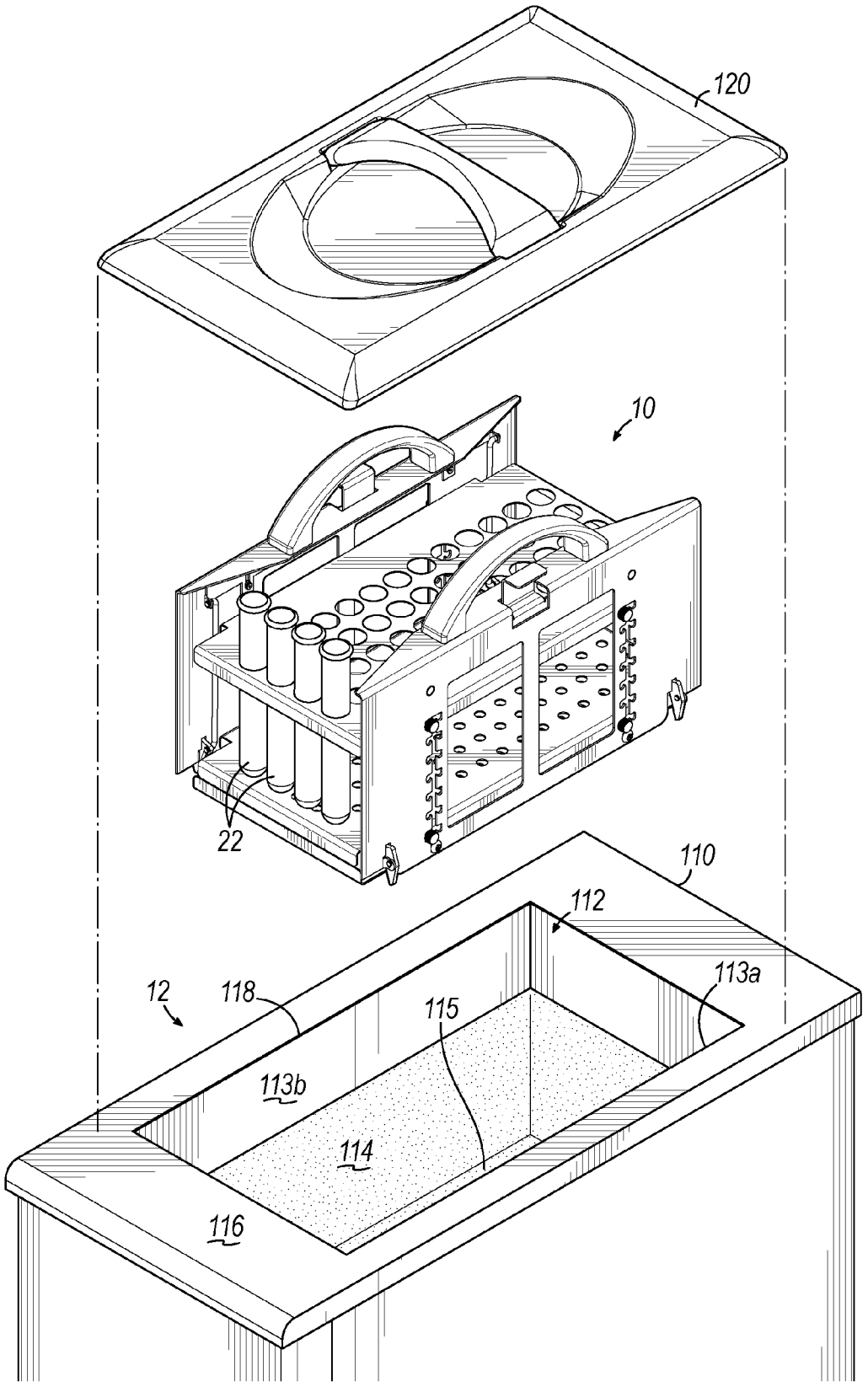
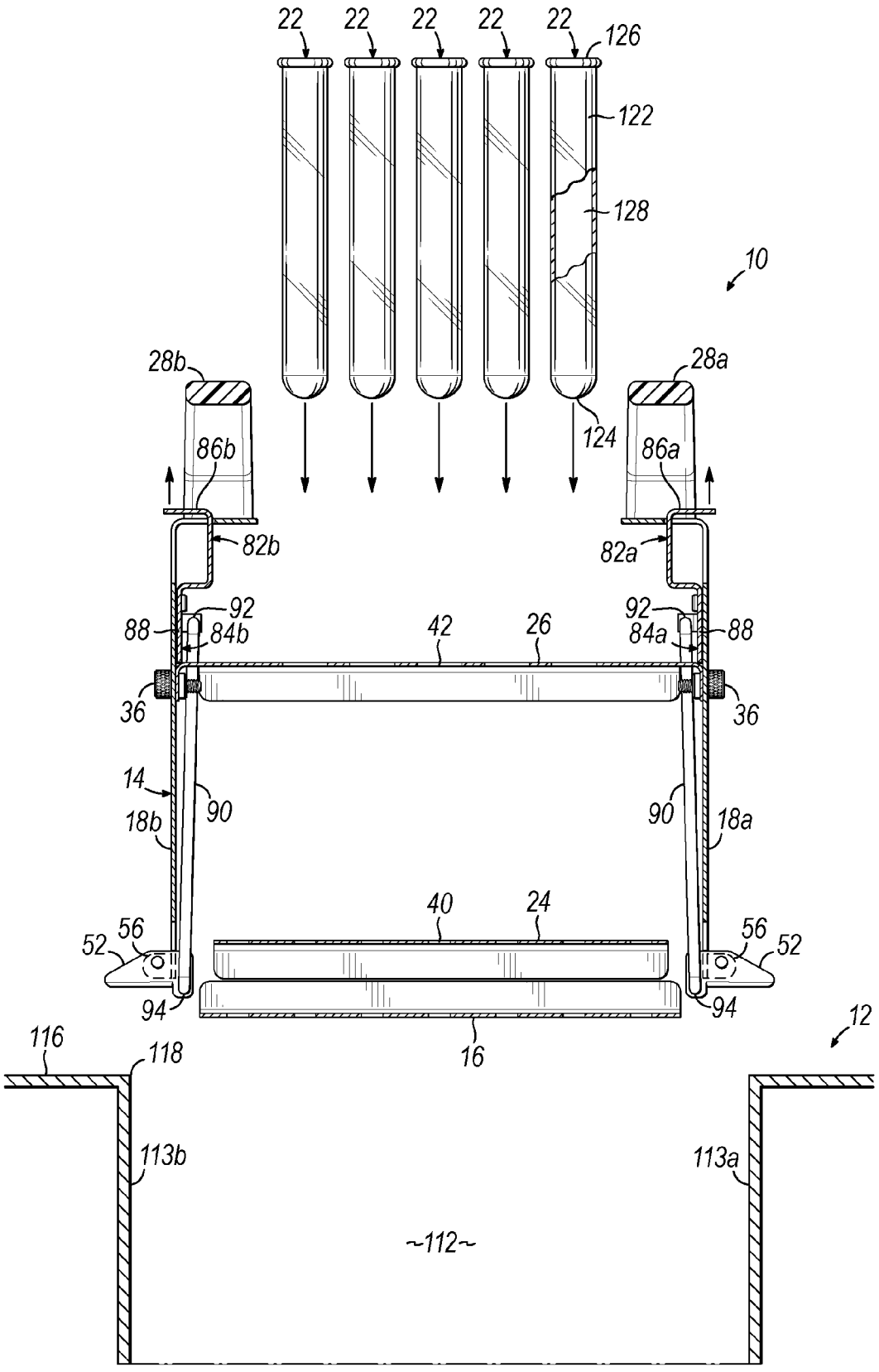



FIG. 5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22
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126
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42
26
92
84a
88
36
36
14
18b
90
90
18a
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56
52
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52
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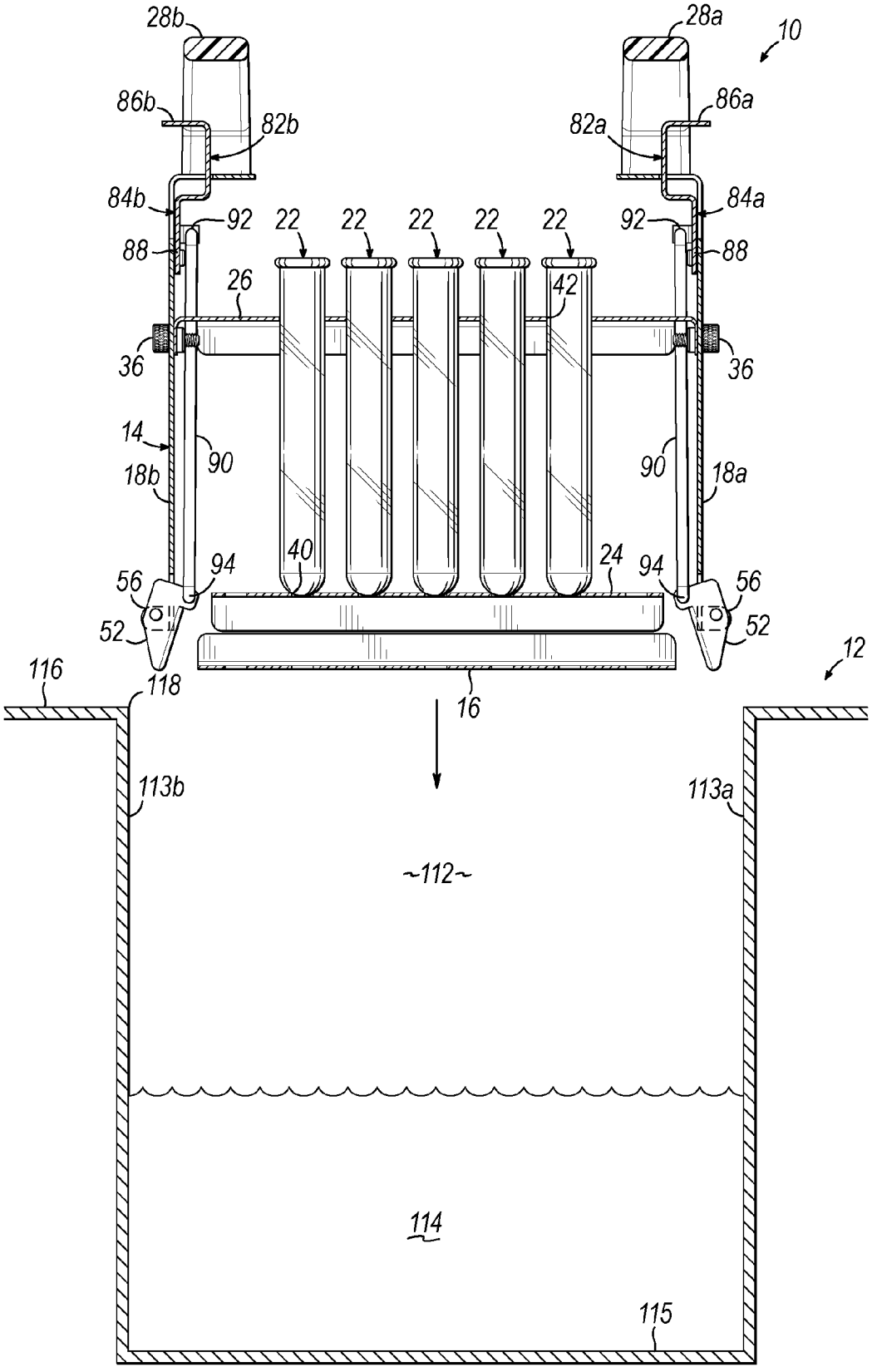
16
113b
113a
~112~

FIG. 6A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42
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18b
18a
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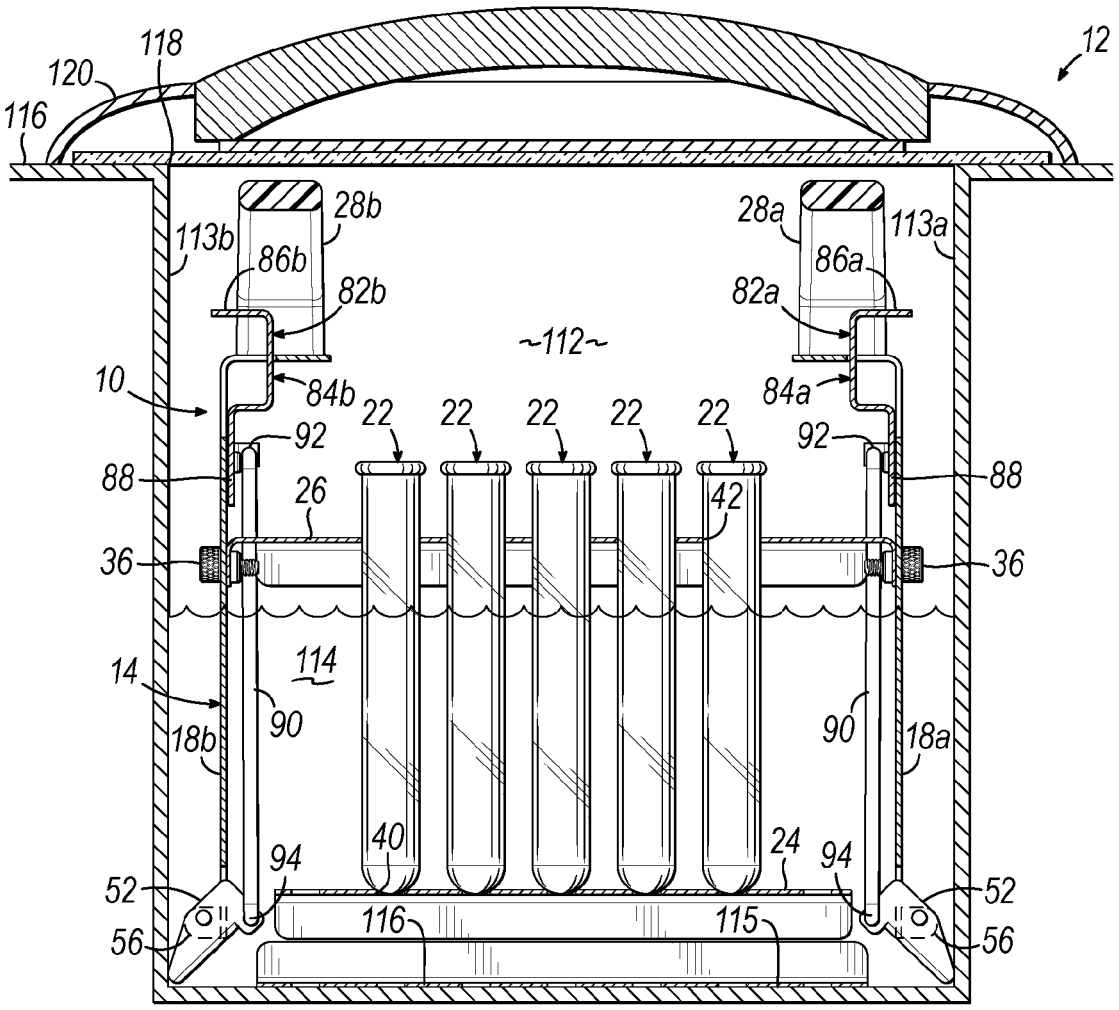
FIG. 6B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92
92
88
88
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18b
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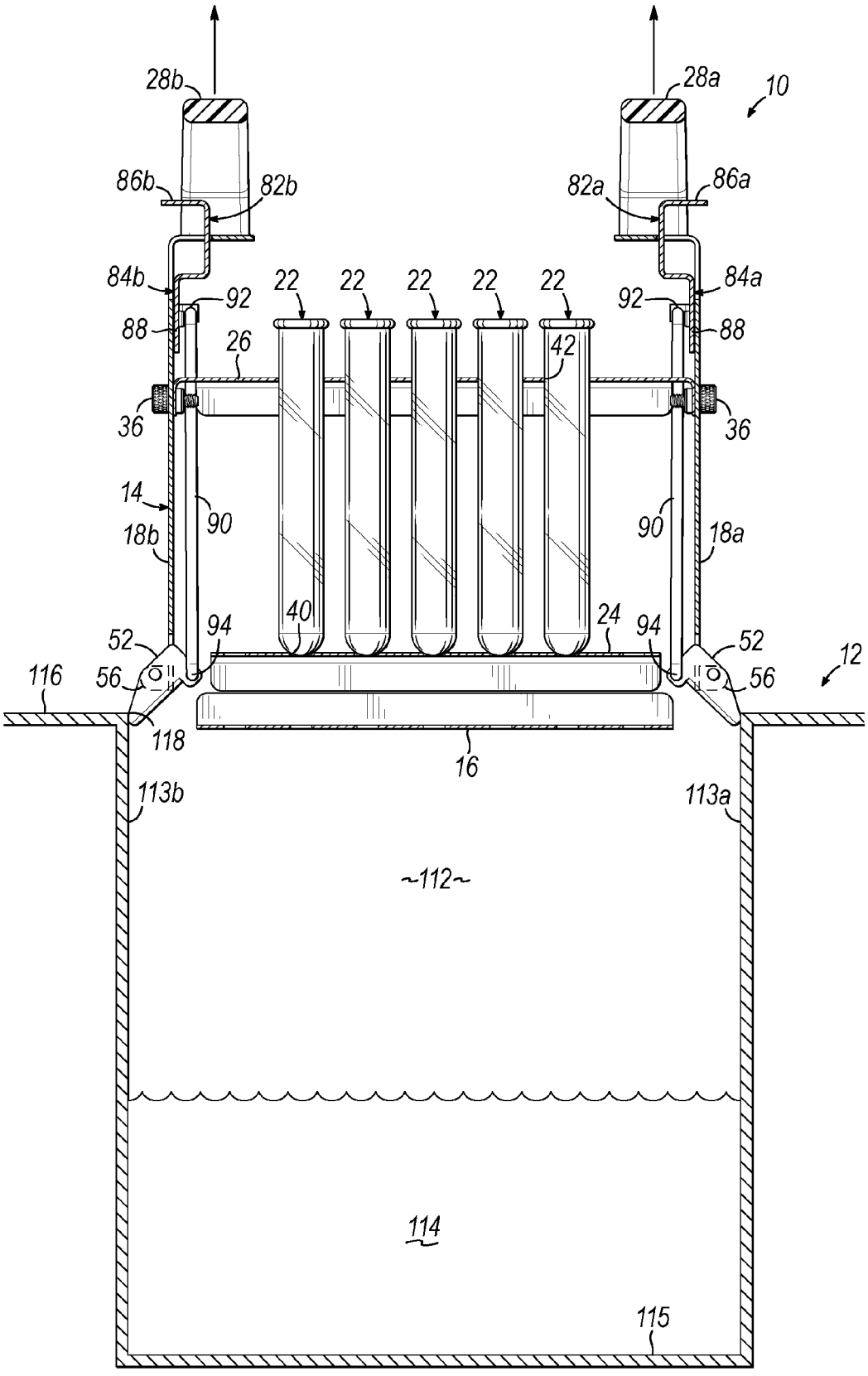
FIG. 6C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18b
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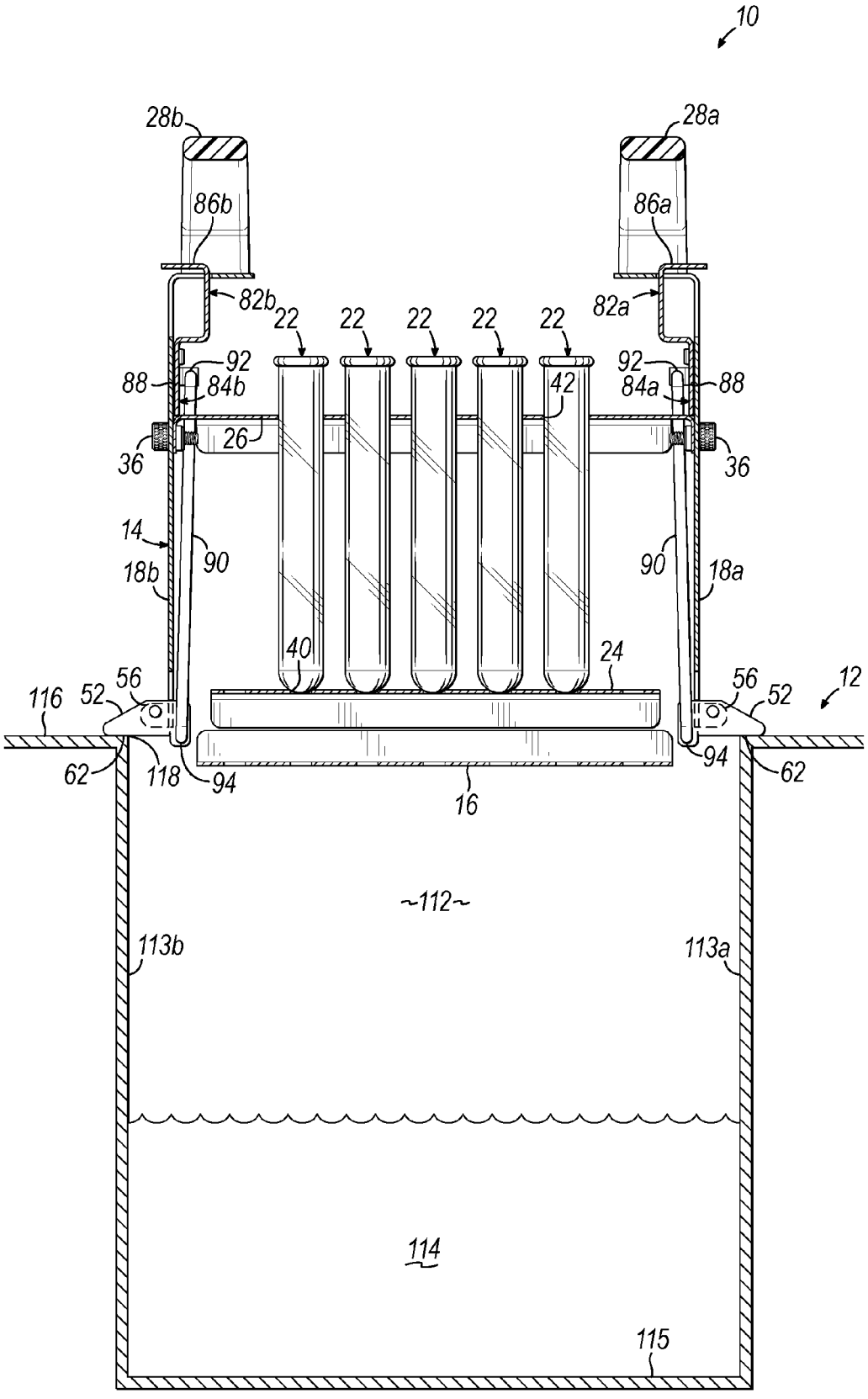
FIG. 6D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86a
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26
36
36
14
90
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18b
18a
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FIG. 6E

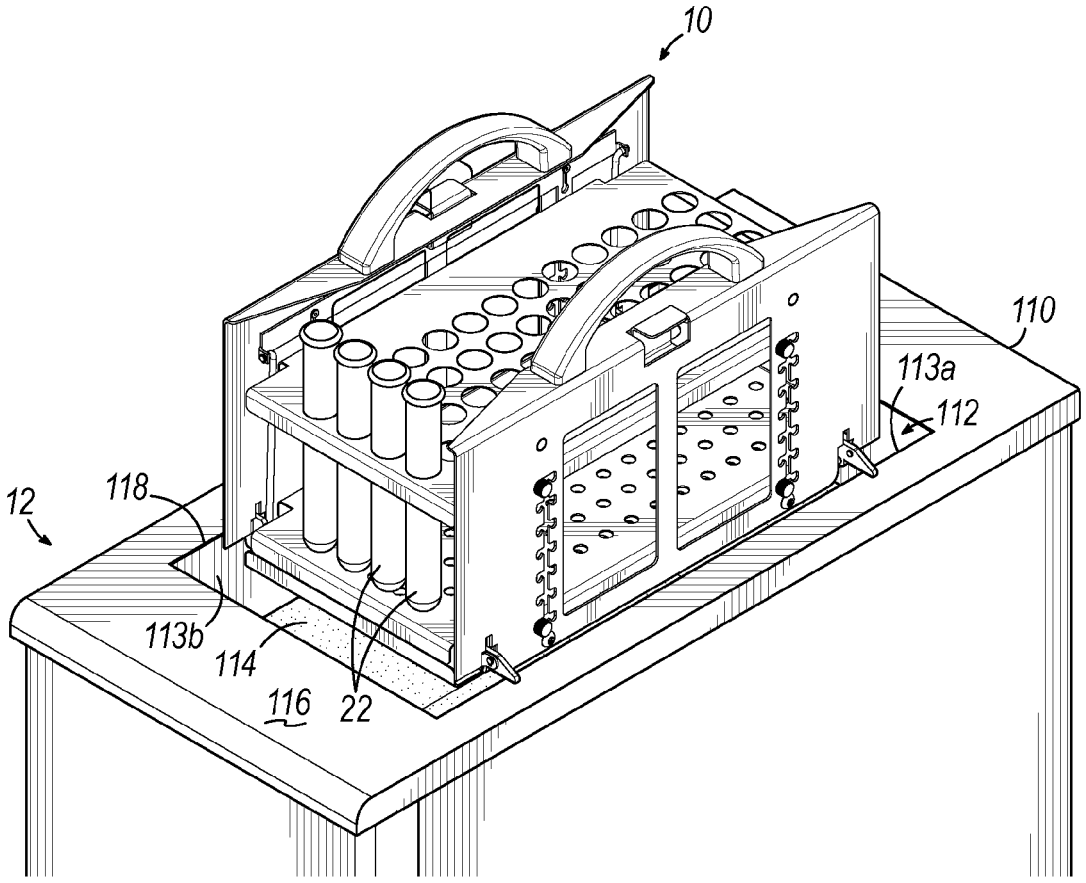


FIG. 7

# RACK FOR USE WITH A TEMPERATURE CONTROLLED BATH, AND A RELATED METHOD

## TECHNICAL FIELD

The present invention relates generally to temperature controlled baths and, more particularly, to racks for supporting vessels in temperature controlled baths.

## BACKGROUND

Temperature controlled baths, such as recirculating baths, are used in laboratory settings for providing a controlled temperature working liquid, such as water, in a reservoir. A user may utilize the temperature controlled bath by placing their material samples in the reservoir or by recirculating the working liquid between the reservoir and an external application. Conventional temperature controlled bath applications include placing material samples into vials, test tubes, beakers or other vessels, and then placing the vessels in the reservoir. The temperature of the working liquid which surrounds the vessels is controlled by the temperature controlled bath to control the temperature of the material samples. For example, the temperature controlled bath may move the working liquid past heating or cooling elements so as to achieve a desired temperature of the working liquid, and thereby control the temperature of the material samples.

Racks are sometimes used to hold the vessels that are placed into a temperature controlled bath. For example, a user may position the vessels in a rack, and then place the rack into the temperature controlled bath such that the vessels are in contact with the working fluid. When the user desires to access the material samples contained in the vessels, the user removes the rack from the temperature controlled bath. Because part of the rack and the vessels had been in contact with the working fluid, a user typically placed the rack into a container, onto a tray, or onto an absorbent material in order to prevent the working fluid from dripping off the rack and/or vessels and contaminating the laboratory setting with working fluid. In addition, the working fluid that is taken out of the reservoir when a rack is removed from the temperature controlled bath diminishes the amount of working fluid in the reservoir. Thus, working fluid must periodically be added to the reservoir in order to replace the working fluid that is taken out.

Thus, there is a need for improvements relating to temperature controlled baths and racks used therewith.

## SUMMARY OF THE INVENTION

The present invention overcomes the foregoing problems and other shortcomings, drawbacks, and challenges of racks for temperature controlled baths. While the invention will be described in connection with certain embodiments, it will be understood that the invention is not limited to these embodiments. To the contrary, this invention includes all alternatives, modifications, and equivalents as may be included within the spirit and scope of the present invention.

In one embodiment of the present invention, a rack is provided for use with a temperature controlled bath having a housing containing a reservoir with a supply of working fluid and an opening providing access to the reservoir. The rack includes a rack body, and a vessel support supported by the rack body and configured for supporting at least one vessel. The rack further includes a supporting foot assembly supported by the rack body and including a plurality of support feet. Each support foot is configured for movement between a stowed position and a deployed position.



In another embodiment of the present invention, a temperature controlled bath is provided in combination with a rack. The temperature controlled bath includes a housing containing a reservoir with a supply of working fluid and an opening providing access to the reservoir. The rack includes a rack body, and a vessel support supported by the rack body and configured for supporting at least one vessel. The rack further includes a supporting foot assembly supported by the rack body and including a plurality of support feet. Each support foot is configured for movement between a stowed position and a deployed position.

In another embodiment of the present invention, a method is provided for using a rack with a temperature controlled bath having a housing containing a reservoir with a supply of working fluid and an opening providing access to the reservoir. The rack supports at least one vessel and includes a supporting foot assembly having a plurality of support feet moveable between a stowed position and a deployed position. The method includes moving the support feet to the stowed position, and lowering the rack into the working fluid in the reservoir.

## BRIEF DESCRIPTION OF THE DRAWINGS

The accompanying drawings, which are incorporated in and constitute a part of this specification, illustrate embodiments of the invention and, together with a general description of the invention given above, and the detailed description of the invention given below, serve to explain the principles of the invention.

FIG. **1** is an isometric view showing a rack that includes a supporting foot assembly for supporting the rack with respect to a temperature controlled bath. The supporting foot assembly includes a plurality of support feet, which are shown in FIG. **1** in a deployed position.

FIG. **1**A is a side elevational view showing an individual support foot as used in the supporting foot assembly of the rack of FIG. **1**.

FIG. **2** is a partially disassembled view of the rack of FIG. **1**, showing an upper tray of a vessel support separated from side walls of the rack.

FIG. **3** is an isometric view of the rack of FIG. **1**, with the support feet being in a stowed position.

FIG. **4** is a schematic elevational view in partial cross section of the rack of FIG. **1**.

FIG. **5** is an isometric view showing the rack of FIG. **1** carrying several vessels and being situated in the environment of a temperature controlled bath, with the support feet being in a stowed position.

FIG. **6**A is a schematic elevational view showing the vessels being lowered into the vessel support of the rack of FIG. **5**, with the rack being positioned above an opening in a housing of the temperature controlled bath, and with the support feet being in a deployed position.

FIG. **6**B is a schematic elevational view showing the rack with vessels of FIG. **5** being lowered into a reservoir of the temperature controlled bath, and with the support feet being in a stowed position.

FIG. **6**C is a schematic elevational view showing the rack with vessels of FIG. **5** with the rack positioned within the reservoir such that the vessels are at least partially surrounded by a working fluid contained in the reservoir.

FIG. **6**D is a schematic elevational view showing the rack with vessels of FIG. **5** being raised through the opening in the housing of the temperature controlled bath.

FIG. **6**E is schematic elevational view showing the rack with vessels of FIG. **5** with the support feet being in a deployed position and resting on an upper surface of the housing of the temperature controlled bath.

FIG. **7** is an isometric view of the configuration shown in FIG. **6**E.

## DETAILED DESCRIPTION

Referring now to the figures, a rack **10** is shown for use with a temperature controlled bath **12** in one exemplary embodiment. The rack **10** will first be described with reference to FIGS. **1**, **1**A, and **2**-**4**, and then the use of the rack **10** with the temperature controlled bath **12** will be described with reference to FIGS. **5**, **6**A-**6**E, and **7**.

The rack **10** generally includes a rack body **14**, which includes a base **16** and two opposed side walls **18***a*, **18***b*. The side walls **18***a*, **18***b* are secured to, and extend generally upwardly from, the base **16**. The rack **10** also includes a vessel support **20** for supporting one or more vessels **22**, such as test tubes, as will be described more fully below. In the particular embodiment shown, the vessel support **20** includes a base tray **24** and an upper tray **26**. The rack **10** also includes handles **28***a*, **28***b* associated with the side walls **18***a*, **18***b*, respectively.

The vessel support **20** is adjustably supported by the side walls **18***a*, **18***b*. In particular, each of the side walls **18***a*, **18***b* includes positioning adjustment slots **30** for adjusting the position of the base tray **24** and the upper tray **26**. Each adjustment slot **30** includes a central channel **32** and a plurality of sockets **34** extending from and connected with the central channel **32**, such as on both sides of the central channel **32**. Retaining members **36** engage the base tray **24** and upper tray **26** to secure them along the adjustment slots **30**. In particular, retaining members **36** extend through the respective side walls **18***a*, **18***b* in the adjustment slots **30** and engage receiving bores **38** formed in the base tray **24** and the upper tray **26**. The retaining members **36** may rest in the sockets **34** of the adjustment slot **30**, for example. As shown, the base tray **24** is supported by the side walls **18***a*, **18***b* generally near the base **16**, and the upper tray **26** is supported by the side walls **18***a*, **18***b* above and spaced from the base tray **24**.

The base tray **24** includes a plurality of apertures **40**, each being configured for receiving part of a vessel **22**, as will be explained further below. In a similar manner, the upper tray **26** includes a plurality of apertures **42**, each being configured for receiving a part of a vessel **22** different from the part received in an aperture **40**, as will also be explained further below. The upper tray **26** has a generally rectangular shape when viewed from the top, except for cutouts **44** formed at corners of the upper tray **26**. Similarly, the base tray **24** has a generally rectangular shape when viewed from the top, except for cutouts **45** formed at corners of the base tray **24**.

The rack **10** also includes a supporting foot assembly **50** supported by the rack body **14**. The supporting foot assembly **50** is configured for supporting the rack **10** with respect to the temperature controlled bath **12**, as will be described further below. In the embodiment shown, the supporting foot assembly **50** includes a plurality of support feet **52**. In particular, the rack **10** includes four support feet **52**, with each support foot **52** being positioned generally near a lower corner **54** of the rack **10**. As shown, two of the support feet **52** are associated with the side wall **18***a*, and two of the support feet **52** are associated with the side wall **18***b*.

The support feet **52** are moveable between a stowed position (FIG. **3**) and a deployed position (FIG. **1**). In the exemplary embodiment shown and described, the support feet **52** are pivotably moveable between the stowed position and the deployed position. Tabs **56** extend outwardly from the side walls **18***a*, **18***b*, and each support foot **52** is pivotably connected to a tab **56** for pivoting movement on a pivot axis **58**. Openings **59** are formed in each side wall **18***a*, **18***b* near the tabs **56**, and the support feet **52** partially extend through the openings **59** such that a portion of each support foot **52** resides generally inside a respective side wall **18***a*, **18***b*, and another portion of each support foot **52** resides generally outside the respective side wall **18***a*, **18***b*. When in the deployed position, a support foot **52** extends outwardly the respective side wall **18***a*, **18***b* (FIG. **1**).

In an alternative embodiment, the support feet **52** may be configured to move between their respective stowed positions and deployed positions in a manner other than pivoting, such as linear or orbital movement, for example.

As shown in FIG. **1**A, each support foot **52** includes an upper surface **60** and an opposed base surface **62**. In the embodiment shown, the upper surface **60** and the base surface **62** are generally parallel. When a support foot **52** is in the deployed position, the base surface **62** is in a generally horizontal orientation (FIG. **1**). When a support foot **52** is in the stowed position, the base surface **62** is in an inclined, non-horizontal, orientation (FIG. **3**).

The upper surface **60** extends for a shorter length than the base surface **62**, and a sloped surface **64** extends downwardly from the upper surface **60** toward the base surface **62**. The sloped surface **64** and the base surface **62** meet at a tip **66**, which may be rounded, as shown. The pivot axis **58** of each support foot **52** extends through a pivot point **68** that is positioned beneath the upper surface **60** and proximate the intersection of the upper surface **60** and the sloped surface **64**.

Generally opposite the tip **66**, the upper surface **60** and the base surface **62** are connected by a back surface **70**. Each support foot **52** includes a heel **72** proximate the back surface **70**, and in particular, proximate the intersection of the back surface **70** and the base surface **62**. In the embodiment shown, the heel **72** extends slightly below the base surface **62**.

An adjustment mechanism **80** is provided for moving or adjusting one or more of the support feet **52**. In particular, the adjustment mechanism **80** may be used to move the support feet **52** to their respective stowed positions, and/or to move the support feet **52** to their respective deployed positions. For example, the adjustment mechanism **80** may be used to move a support foot **52** between (1) its stowed position and (2) its deployed position, or between (1) its deployed position and (2) its stowed position. Also, the adjustment mechanism **80** may be used to move a support foot **52** between (1) any position intermediate its stowed position and its deployed position and (2) the stowed position or, between (1) any position intermediate its stowed position and its deployed position and (2) the deployed position.

In the embodiment shown, the adjustment mechanism **80** includes aspects associated with one side of the rack body **14**, and similar aspects associated with another side of the rack body. In particular, the adjustment mechanism **80** includes finger-actuated levers **82***a*, **82***b* and linkages **84***a*, **84***b*. The linkages **84***a*, **84***b* operatively connect the respective levers **82***a*, **82***b* with at least one of the support feet **52** associated with the respective side walls **18***a*, **18***b*. In particular, the lever **82***a* is operatively connected with the two support feet **52** associated with the side wall **18***a* via the linkage **84***a*. The lever **82***a* and linkage **84***a* are shown in

FIG. **4**, for example. Similarly, the lever **82***b* is operatively connected with the two support feet **52** associated with the side wall **18***b* via the linkage **84***b*. The views provided in FIGS. **6**A-**6**E show the lever **82***a* and linkage **84***a* are associated with one side of the rack body **14**, and the lever **82***b* and linkage **84***b* are associated with another side of the rack body **14**.

As shown, the levers **82***a*, **82***b* are positioned proximate the handles **28***a*, **28***b*, and include generally horizontally-extending finger tabs **86***a*, **86***b*. The levers **82***a*, **82***b* may be moved in the up-down direction, such as by engaging the finger tabs **86***a*, **86***b*. The linkages **84***a*, **84***b* are positioned generally inside the side walls **18***a*, **18***b*.

Each linkage **84***a*, **84***b* includes a crossbar **88** connected with and positioned beneath an associated respective lever **82***a*, **82***b*. Each crossbar **88** is connected with the associated support feet **52** via connector rods **90**. In particular, each crossbar **88** is connected with a connector rod **90** at a connection **92**. Each connector rod **90** extends downwardly from the crossbar **88** through the cutouts **44** of the upper tray **26** and the cutouts **45** of the base tray **24** and is connected with a support foot **52** at a connection **94**. In particular, a connector rod **90** is connected at the connection **94** with the heel **72** of a support foot **52**. The connections **92** between the connector rods **90** and the crossbars **88** may be a pivotable connection, for example. Similarly, the connections **94** between the connector rods **90** and the support feet **52** may also be a pivotable connection, for example.

Up-down movement of the levers **82***a*, **82***b* thereby causes corresponding up-down movement in the linkages **84***a*, **84***b*. Up-down movement of the linkages **84***a*, **84***b*, in turn, causes pivotal movement of the support feet **52** about the respective pivot axes **58**. In particular, upward movement of the levers **82***a*, **82***b* cause the support feet **52** to pivot toward their respective stowed positions. Downward movement of the levers **82***a*, **82***b* cause the support feet **52** to pivot toward their respective deployed positions.

The movement of the levers **82***a*, **82***b* and/or the linkages **84***a*, **84***b* may be constrained such that the support feet **52** cannot be moved beyond the stowed and deployed positions. To that end, a limit assembly **96** can be provided for limiting the extent of up-down movement of the linkages **84***a*, **84***b*. In particular, each of the linkages **84***a*, **84***b* includes two such limit assemblies **96**. Each limit assembly **96** includes a guide channel **98** extending through the crossbar **88**, and a post **100** extending from a respective side wall **18***a*, **18***b* and received in the guide channel **98**. Each guide channel **98** extends between an upper end **102** and a lower end **104**. The crossbar **88** may be moved downwardly until the posts **100** reach the upper ends **102** of the guide channels **98** and stop further downward movement of the crossbar **88**. In the other direction, the crossbar **88** may be moved upwardly until the posts **100** reach the lower ends **104** of the guide channels **98** and stop further upward movement of the crossbar **88**. In addition to limiting the extent of movement of the crossbar **88**, the guide channel **98** also limits the direction of movement of the crossbar **88** to the up-down direction.

In some embodiments of the present invention, the support feet **52** may be configured to automatically move to their respective deployed positions. For example, the weight of the adjustment mechanism **80**, including the levers **82***a*, **82***b* and the linkages **84***a*, **84***b* may tend to cause the support feet **52** to pivot toward their respective deployed positions. The support feet **52** may be moved to their respective stowed positions by moving the levers **82***a*, **82***b* and linkages **84***a*, **84***b* upwardly. The support feet **52** will remain in the stowed position so long as the levers **82***a*, **82***b* and linkages **84***a*, **84***b* are held upwardly. Once the levers **82***a*, **82***b* are released, the weight of the levers **82***a*, **82***b* and linkages **84***a*, **84***b* may cause them to move downwardly, thereby causing the support feet **52** to automatically move to their respective deployed positions.

In other embodiments of the present invention, the support feet **52** may not automatically move to any position. Rather, the support feet **52** may be selectively moved to their respective stowed and deployed positions using the adjustment mechanism **80**, including the levers **82***a*, **82***b* and the linkages **84***a*, **84***b*. In addition, the support feet **52** may be selectively moved to their respective stowed and deployed positions by manipulating the support feet **52** themselves, such as by pushing or pulling on any of the upper surface **60**, the base surface **62**, the sloped surface **64**, the tip **66**, the back surface **70**, and the heel **72**.

Referring next to FIGS. **5**, **6**A-**6**E, and **7**, use of the rack **10** with the temperature controlled bath **12** is now described. The temperature controlled bath **12** includes a housing **110** that holds a reservoir **112** with a supply of working fluid **114**. The reservoir **112** generally includes reservoir side walls **113***a*, **113***b*, and a reservoir base **115**. The reservoir side walls **113***a*, **113***b* extend upwardly from the reservoir base **115**. The temperature controlled bath **12** may include one or more temperature control units, such as a heating unit and/or a cooling unit, for adjusting the temperature of the working fluid **114** in the reservoir **112**.

The housing **110** includes an upper surface **116**. An opening **118** in the upper surface **116** provides access to the reservoir **112** and the working fluid **114** therein. The temperature controlled bath **12** may also include a lid **120** that mates with the housing **110** to cover the opening **118**.

As discussed above, the rack **10** includes the vessel support **20** for supporting one or more vessels **22**. In the embodiment shown, the vessels **22** are in the form of test tubes, but it will be appreciated that other forms of vessels can also be used with the rack **10**, such as vials, beakers, and other containers. Each vessel **22** generally includes a vessel body **122** that extends between a base end **124** and an upper end **126**. For the vessels **22** shown, the base end **124** is rounded and closed, and the upper end **126** is open. The vessel bodies **122** provide an internal space **128** for containing a material sample.

The vessels **22** are supported by the vessel support **20** as follows. As shown in FIG. **6**A, the vessels **22** are positioned above the upper tray **26** of the vessel support **20**. In particular, the vessels **22** are aligned with the apertures **42** in the upper tray **26**. The vessels **22** are lowered through the apertures **42** toward the base tray **24**. The vessels are further lowered until the base ends **124** reach the base tray **24** and are received in the apertures **40** of the base tray **24**, as shown in FIG. **6**B. In that position, the apertures **40** receive a portion of the vessel bodies **122**, and the apertures **42** receive another portion of the vessel bodies **122** (generally, the base ends **124**). The apertures **40**, **42** may also provide pathways for working fluid **114** to drain off the vessels **22** and the rack **10**, for example. To that end, the rack **10** may also include apertures that provide similar drainage pathways for working fluid **114**.

The rack **10** having the vessels **22** may be put into the temperature controlled bath **12**. For example, a user can grasp the rack **10** by the handles **28***a*, **28***b* and hold the rack **10** above the temperature controlled bath **12**. As shown in FIG. **6**B, the rack **10** with the vessels **22** is positioned above the opening **118** in the housing **110** of the temperature controlled bath **12**. The support feet **52** are moved to their respective stowed positions, if they are not already in the

stowed position. For example, the adjustment mechanism **80** may be operated to move the support feet **52** to their respective stowed positions. With the support feet **52** in the stowed position, the rack **10** can fit between the reservoir side walls **113***a*, **113***b* and can be lowered into the reservoir **112**. In particular, the rack **10** can be lowered into the reservoir **112** so that the vessels **22** come into contact with the working fluid **114**.

As shown in FIG. **6**C, the rack **10** is lowered into the reservoir **112** until it rests on the reservoir base **115**. In that position, the rack **10**, and in particular the vessel support **20**, supports the vessels **22** in the working fluid **114**. The temperature of the working fluid **114** is controlled by the temperature controlled bath **12**. The vessels **22** are in thermal contact with the working fluid **114** which surrounds them, and thereby the temperature controlled bath **12** can provide control of the temperature of the material sample contained in the vessels **22**. For example, the working fluid **114** can be maintained at a cool temperature to maintain the vessels **22** and their material sample at a cool temperature. Alternatively, the working fluid **114** can be maintained at a warm temperature to maintain the vessels **22** and their material sample at a warm temperature. As also shown in FIG. **6**C, the lid **120** may be placed over the opening **118** when the rack **10** is inside the reservoir **112**.

The rack **10** may be raised out of the reservoir **112**, as shown in FIG. **6**D. For example, a user can grasp the rack **10** by the handles **28***a*, **28***b* and lift the rack **10** upwardly. A user may remove the rack **10** from the reservoir **112** in order to gain access to the vessels **22**, for example. The rack **10** is raised upwardly and through the opening **118** in the housing **110**. The support feet **52** generally do not impede the rack **10** from being raised in the reservoir **112**, even if the support feet **52** engage the reservoir side walls **113***a*, **113***b*. For example, even if the support feet **52** tend to move toward their respective deployed positions, the reservoir side walls **113***a*, **113***b* may constrain the support feet **52** from reaching respective deployed positions, as shown in FIGS. **6**C and **6**D.

Once the rack **10** is raised to an appropriate level, the support feet **52** are moved to their respective deployed positions. In some embodiments, the support feet **52** automatically move to their respective deployed positions when the support feet **52** are raised through or past the opening **118** and are no longer constrained from pivoting to the deployed position by the reservoir side walls **113***a*, **113***b*. In other embodiments, the support feet **52** may be manually moved to their respective deployed positions. For example, a user can operate the adjustment mechanism **80** or the support feet **52** can be engaged themselves to move the support feet **52** to their respective deployed positions.

Once the support feet **52** are in their respective deployed positions, the rack **10** can be rested on the housing **110** of the temperature controlled bath **12**, as shown in FIGS. **6**E and **7**. In particular, the base surfaces **62** of the support feet **52** can rest on the upper surface **116** of the housing **110**. When the support feet **52** are in their respective deployed positions, the support feet **52** prohibit the rack **10** from being lowered into the working fluid **114** in the reservoir **112**. As shown in FIGS. **6**E and **7**, the supporting foot assembly **50**, including the support feet **52**, support the rack **10** in such a manner that much of the rack **10**, including the vessel support **20** and the vessels **22**, is suspended over the opening **118** of the housing **110** above the working fluid **114** in the reservoir **112**. Thereby, any residual working fluid **114** on the rack **10** or the vessels **22** can drain back into the reservoir **112**, which is directly beneath the rack **10**.

When it is desired to place the rack **10** back into the reservoir **112**, a user moves the support feet **52** to their respective stowed positions, as discussed above, and lowers the rack **10**, as also discussed above.

Advantageously, because the rack **10** may be placed on the temperature controlled bath **12**, it is not necessary to place the rack **10** into another container, onto a tray, or onto an absorbent material when the rack **10** is removed from the temperature controlled bath **12**. And since the rack **10** rests directly above the reservoir **112**, the working fluid **114** can drain directly back into the reservoir **112**. The working fluid **114** is thereby less likely to be spread around and contaminate the laboratory setting. In addition, the supply of working fluid **114** in the reservoir **112** is not diminished, thereby eliminating the need to replenish the working fluid that arose with prior racks.

Further advantageously, the rack **10** is usable with many types of temperature controlled baths, and with many types of vessels or other containers. Where the support feet **52** automatically move to their respective deployed positions, a user can simply raise the rack **10** from the reservoir **112** and immediately set the rack **10** to rest on the upper surface **116** of the housing **110**. Thus, no additional steps for moving the support feet **52** to their respective deployed positions are required. In addition, the rack **10** can be put back into the reservoir **112** by moving the support feet **52** to their respective stowed positions and lowering the rack **10** into the reservoir **112**.

While the present invention has been illustrated by the description of the embodiments thereof, and while the embodiments have been described in considerable detail, it is not the intention of the applicant to restrict or in any way limit the scope of the appended claims to such detail. Additional advantages and modifications will readily appear to those skilled in the art. Therefore, the invention in its broader aspects is not limited to the specific details of the representative apparatus and method, and illustrative examples shown and described. Accordingly, departures may be made from such details without departing from the spirit or scope of Applicants' general inventive concept.

What is claimed is:

**1**. A rack for placement into a temperature controlled bath having a housing containing a reservoir with a supply of working fluid and an opening providing access to the reservoir, the rack comprising:

a rack body;

a vessel support supported by the rack body and configured for supporting at least one vessel;

a supporting foot assembly supported by the rack body and including a plurality of support feet, each support foot being configured for movement between a stowed position and a deployed position; and

a user-operated adjustment mechanism operatively connected to at least one support foot and being configured to move the at least one support foot from the deployed position to the stowed position, the adjustment mechanism including a finger-actuated lever and a linkage operatively connecting the lever with the at least one support foot.

**2**. The rack of claim **1**, further comprising a handle, the finger-actuated lever being positioned proximate the handle.

**3**. The rack of claim **1**, each support foot being configured for automatically moving to the deployed position.

**4**. The rack of claim **1**, each support foot including an upper surface, a base surface opposed from the upper surface, and a sloped surface extending from the upper surface toward the base surface.

5. The rack of claim 1, the supporting foot assembly including four support feet.

6. The rack of claim 5, each support foot being positioned generally near a lower corner of the rack.

7. The rack of claim 1, the rack body comprising a base, a first side wall, and a second side wall, the first and second side walls extending upwardly from the base and supporting the vessel support, and wherein each support foot extends outwardly from one of the first and second side walls when moved to the deployed position.

8. The rack of claim 7, the supporting foot assembly including two support feet associated with the first side wall and two support feet associated with the second side wall.

9. In combination,

a temperature controlled bath having a housing containing a reservoir with a supply of working fluid and an opening providing access to the reservoir, and

a rack for placement into a temperature controlled bath, the rack comprising:

a rack body;

a vessel support supported by the rack body and configured for supporting at least one vessel;

a supporting foot assembly supported by the rack body and including a plurality of support feet, each support foot being configured for movement between a stowed position and a deployed position; and

a user-operated adjustment mechanism operatively connected to at least one support foot and being configured to move the at least one support foot from the deployed position to the stowed position, the adjustment mechanism including a finger-actuated lever and a linkage operatively connecting the lever with the at least one support foot.

10. The rack of claim 9, wherein when the support feet are moved to the stowed position, the rack can be lowered into the working fluid in the reservoir, and when the support feet are moved to the deployed position, the rack is prohibited from being lowered into the working fluid in the reservoir.

11. The rack of claim 9, the housing having an upper surface, and each support foot including a base surface configured for resting on the upper surface when the support feet are moved to the deployed position, the base surface being in a generally horizontal orientation in the deployed position and in an inclined orientation in the stowed position.

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